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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hidemasa KAI**

Group Art Unit: **1763**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND  
SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**  
Customer Number: **38834**

**RESPONSE UNDER 37 C.F.R. §1.116**  
**EXPEDITED PROCESSING REQUESTED**

**MAIL STOP AF**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 7, 2006

Sir:

In response to the Office Action dated May 8, 2006, Applicants submit the following remarks.

Remarks begin on page 2 of this paper.